

Application/Control No.	Applicant(s)/Patent under Reexamination	
09/983,041	SHIBUYA, ATSUSHI	
Examiner	Art Unit	
Hai V. Nguyen	2142	

SEARCHED					
Class	Subclass	Date	Examiner		
709	219	2/11/2006			
709	206	2/11/2006	-		

INTERFERENCE SEARCHED					
Class	Subclass	Date	Examiner		
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SEARCH NOTES (INCLUDING SEARCH STRATEGY)			
	DATE	EXMR	
EAST Search updated	2/11/2006	HN	

